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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/787,164	02/27/2004	Takanori Teshima	01-279-CON	4896
23400	7590 11/22/2004		EXAM	INER
POSZ & BETHARDS, PLC 11250 ROGER BACON DRIVE		WILLIAMS, AL	WILLIAMS, ALEXANDER O	
SUITE 10			ART UNIT	PAPER NUMBER
RESTON, VA	A 20190		2826	

DATE MAILED: 11/22/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)				
Office Antique Commune	10/787,164	TESHIMA, TAKANORI				
Office Action Summary	Examiner	Art Unit				
	Alexander O Williams	2826				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) days will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	nely filed s will be considered time the mailing date of this c (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 26 Au	ugust 2004.					
2a) ☐ This action is FINAL . 2b) ☒ This	action is non-final.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims						
4) ☐ Claim(s) 1-3 and 7-9 is/are pending in the applied 4a) Of the above claim(s) is/are withdraw 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-3 and 7-9 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or	vn from consideration.		,			
Application Papers						
9) The specification is objected to by the Examiner 10) The drawing(s) filed on is/are: a) access applicant may not request that any objection to the of Replacement drawing sheet(s) including the correction of the original than the correction of the correction of the original than the correction of the correc	epted or b) objected to by the Edrawing(s) be held in abeyance. See ion is required if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 C	` '			
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) △ All b) ☐ Some * c) ☐ None of: 1. ☐ Certified copies of the priority documents have been received. 2. △ Certified copies of the priority documents have been received in Application No. 10/127613. 3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.						
Attachment(s)	 .					
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	4)	te	D-152)			

Serial Number: 10/787164 Attorney's Docket #: 01-279-CON

Filing Date: 2/27/04; claimed foreign priority to 4/25/2001

Applicant: Teshima

Examiner: Alexander Williams

This is a continuation of serial # 10/127613, filed 4/23/02.

Applicant's Amendment filed 8/26/04 has been acknowledged.

The disclosure is objected to because of the following informalities: The continuation application information should be updated.

Appropriate correction is required.

Claims 4 to 6 and 10 to 16 have been canceled.

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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Claim 1 to 3, 7 and 9 are rejected under 35 U.S.C. 102(b) as being anticipated by Kumamo Shoji (Japan Patent Application # 58-34951).

For example, in claim 1, Kumamo Shoji (figures 1 to 12) specifically figure 8 show a semiconductor device comprising: a semiconductor chip 12, which produces heat when operated; a heat conducting plate 13,14 for conducting heat provided on one side of the semiconductor chip; an insulating sheet (being that a mold retainers are made of an insulating material in which can be a insulating sheet 18,21), which is compressive is deformable also provided on the one side of the semiconductor chip; and a resin molding 16 covering the semiconductor chip, the plate, and the sheet such that the sheet is exposed (outer surfaces of 18,21) from the resin molding.

- 2. The semiconductor device of claim 1, Kumamo Shoji show wherein the heat conductivity of the insulating sheet is greater than that if the resin molding (inherit, since the same materials are used).
- 3. The semiconductor device of claim 2, Kumamo Shoji show wherein the insulating sheet is made of silicone rubber.
- 7. The semiconductor device of claim 1, Kumamo Shoji show wherein the insulating sheet (inside under end portions of 18,21) is adhered to the heat conducting plate (outer side portions of 13,14) using a coating resin 16 applied to heat conducting plate.
- 9. The semiconductor device of claim 1, Kumamo Shoji show wherein the semiconductor chip forms part of a stack, and the stack includes the plate, and opposite sides of the semiconductor chip are soldered (by 12a,12b) to members of the stack (see figure 4).

Claim 8 is rejected under 35 U.S.C. § 103(a) as being unpatentable over Kumamo Shoji (Japan Patent Application # 58-34951) in view of Eguchi et al. (U.S. Patent # 6,627,997 B1).

Kumamo Shoji show the features of the claimed invention as detailed above, but fail to explicitly show wherein the coating resin is polyamide resin. However, Kumamo Shoji does discloses a sealing resin. It is understood that one of ordinary skill in the art known that a sealing resin can be a polyamide resin.

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Eguchi et al. is cited for showing a semiconductor module. Specifically, Eguchi et al. (figures 1A to 11E) specifically figure 10E discloses the coating resin is polyamide resin for the purpose of attaining high density mounting, narrow pitch/multi-pin connection, low noise, and low heat resistance.

Summary of Invention Paragraph - BSTX (33):

[0030] As thermoplastic resins there may be used polyimide or polyamide resins for example.

Detail Description Paragraph - DETX (45):

[0094] Using a mixture (weight ratio 1:1) of a thermoplastic polyimide and a

thermoplastic polyamide-imide as the resin composition 5 a semiconductor module

was fabricated in accordance with the method illustrated in FIGS. 10A to 10G.

Therefore, it would have been obvious to one of ordinary skill in the art to use Eguchi et al.'s polyamide coating resin to modify Inoue's sealing resin for the purpose of attaining high density mounting, narrow pitch/multi-pin connection, low noise, and low heat resistance.

Response

Applicant's arguments filed 8/26/04 have been fully considered, but are most in view of the new grounds of rejections detailed above.

The listed references are cited as of interest to this application, but not applied at this time.

Field of Search	Date
U.S. Class and subclass: 257/718,712,713,675,777,723,685,686,707,720,717,787, 790,788,791,792,795,796,684	6/9/04 11/16/04
Other Documentation: foreign patents and literature in 257/718,712,713,675,777,723,685,686,707,720,717,787, 790,788,791,792,795,796,684	6/9/04 11/16/04
Electronic data base(s): U.S. Patents EAST	6/9/04 11/16/04

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alexander O Williams whose telephone

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number is (571) 272 1924. The examiner can normally be reached on M-F 6:30-7:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan Flynn can be reached on (571) 272 1915. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

AOW 11/17/04

> Primary Examiner Alexander O. Williams